



Form PTO-1449

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

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Docket Number Optional
16139/09014Application Number
09/954,194

Applicant

Michael L. Myrick, et al.

Filing Date
September 26, 2001Group Art Unit
1762

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER							DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
WA	4	0	8	4	8	8	0	04/18/1978	Clow	350	3.72	
	4	1	1	8	1	0	6	10/03/1978	Leith	350	96.25	
	4	6	8	7	3	3	5	08/18/1987	Zupanick, et al.	356	416	
	4	8	2	1	3	3	8	04/11/1989	Naruse, et al.	455	617	
	4	9	3	4	7	8	2	06/19/1990	Soffer, et al.	350	162.12	
	5	0	0	5	9	4	6	04/09/1991	Brandstetter	350	162.12	
	5	0	2	9	2	4	5	07/02/1991	Keranen, et al.	250	205	
	5	0	9	0	8	0	7	02/25/1992	Tai	356	310	
	5	1	9	4	9	2	1	03/16/1993	Tambo, et al.	356	432	
	5	2	8	9	2	8	9	02/22/1994	Nagasaki	358	432	
	5	3	2	1	5	3	9	06/14/1994	Hirabayashi, et al.	359	94	
	5	4	1	2	4	6	5	05/02/1995	Baylor, et al.	356	301	
	5	4	2	4	5	4	5	06/13/1995	Block, et al.	250	343	
	5	4	5	9	6	7	7	10/17/1995	Kowalski, et al.	364	571.02	
	5	4	7	9	1	6	4	12/26/1995	Yorks, et al.	341	50	
	5	5	1	3	0	2	2	04/30/1996	Son, et al.	359	16	
WA	5	5	5	5	1	2	8	09/10/1996	Khoury, et al.	359	559	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER							DATE	COUNTRY	CLASS	SUBCLASS	Translation	
												YES	NO
WA	0	6	0	0	3	3	4	06/08/94	Europe				X
WA	0	4	0	0	1	5	5	07/01/1992	Japan				X
WA	1	1	5	0	6	2	0	02/06/1999	Japan				X
WA	1	1	5	0	6	2	0	02/06/1999	Japan				X
WA WO	9	6	3	0	7	4	6	10/03/1996	PCT			X	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

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Form PTO-1449

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Docket Number Optional
16139/09014

Application Number
09/964,194

Applicant

Michael L. Myrick, et al.

Filing Date
September 26, 2001

Group Art Unit
2877

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
WA	5 7 1 7 6 0 5	02/10/1998	Komiya, et al.	364	526	
	5 7 3 7 0 7 6	04/07/1998	Glaus, et al.	356	310	
	5 7 4 7 8 0 6	05/05/1998	Khalil, et al.	250	339.12	
	5 7 5 0 9 9 4	05/12/1998	Schlager	250	339.11	
	5 7 7 1 0 9 6	06/23/1998	Andersen	356	346	
	5 8 2 8 4 9 2	10/27/1998	Moser, et al.	359	575	
	5 9 4 5 6 7 6	08/31/1999	Khalil, et al.	250	339.12	
	6 0 4 0 5 7 8	03/21/2000	Malin, et al.	250	339.12	
	6 1 9 8 5 3 1	03/06/2001	Myrick, et al.	356	300	
WA	6 2 3 6 0 4 7	05/22/2001	Malin, et al.	250	339.12	

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FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
					YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

WA	Photographs of Buhler System
WA	J.A. Dobrowolski and R.A. Kemp, "Refinement of Optical Multilayer Systems With Different Optimization Procedures," Applied Optics, Vol. 29; No. 19, July 1990, pp. 2876-93
WA	Brian T. Sullivan and J.A. Dobrowolski, "Implementation of Numerical Needle Method for Thin-Film Design," Applied Optics, Vol. 35; No. 28, October 1996, pp. 5484-92
WA	A.G. Ryabenko and G.G. Kasparov, "An Algorithm for Constructing the Basis of Optimal Linear Combinations. Spectral Determination of Aerosol Impurities against the Background of a Water Aerosol with an Arbitrary Particle Size Distribution," Pattern Recognition and Image Analysis, Vol. 3; No. 1, March 1993, pp. 348-54
WA	A.G. Ryabenko and G.G. Kasparov, "Numerical Study of a Pattern Recognition Multispectral System with Optimal Spectral Splitting," Pattern Recognition and Image Analysis, Vol. 1; No. 3, 1991, pp. 57-68
WA	Vasil'ev, et al, "Rotational and Vibrational Deactivation of Excited HF Molecules," Sov. Physics - JETP, Vol. 41; No. 4, 1976, pp. 617-21
WA	Moravskii, et al., "Spectrophotometric Determination of the Yield of the C ₆₀ and C ₇₀ Fullerenes in Electric Arc Synthesis under Helium," Journal of Analytical Chemistry, Vol. 53; No. 12, 1998, pp. 1135-42
WA	International Search Report, January 19, 1999
WA	International Search Report; January 21, 2000

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WA

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9/19/05

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